



PATENT
Atty. Dkt. SOEI/0030

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Arimura, et al.

Serial No.: 09/807,902

Confirmation No.: 7482

Filed: April 19, 2001

For: WAFER SUPPORT IN
SEMICONDUCTOR
PRODUCTION APPARATUS

Group Art Unit: 1763

Examiner: Bueker, Richard

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Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>12/13</u> , 2002 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231.	
<u>12/13/02</u> Date	<u>[Signature]</u> Signature

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

12/11/2002 DEHMANU1 00000049 200782 09807902

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The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

Applicants certify that all references submitted with this disclosure were first cited in a communication from a foreign patent office dated October 23, 2002, which communication is enclosed, not more than three months prior to the filing of this Supplemental Information Disclosure Statement.

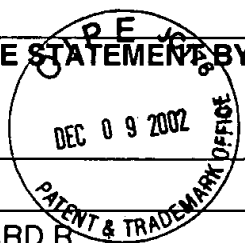
If the sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/SOEI/0030/KMT.

Respectfully submitted,



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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. SOEI/0030	Serial No. 09/807,902
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant ARIMURA, ET AL.	Confirmation No.: 7482
(Use several sheets if necessary)		Filing Date APRIL 19, 2001	Group 1763
Examiner BUEKER, RICHARD R.			

**U.S. Patent Documents**

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
	A1	5,318,634	06/07/1994	DeBoer, et al.	118	730	02/14/1991
	A2						
	A3						
	A4						
	A5						
	A6						
	A7						
	A8						
	A9						
	A10						
	A11						

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Foreign Patent Documents

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
	B1	EP 0 471 365 A1	02/19/1992	Europe	C23C	16/44	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B2	WO 97/08743	03/06/1997	WIPO	H01L	21/00	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B3	WO 97/09737	03/13/1997	WIPO	H01L	21/00	<input type="checkbox"/>	<input checked="" type="checkbox"/>
	B4	WO 99/23691	05/14/1999	WIPO	H01L	21/00	<input type="checkbox"/>	<input checked="" type="checkbox"/>

OTHER ART

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
	C1	EP Search Report for MJD/57623/000 dated October 23, 2002.
	C2	
	C3	

Examiner	Date Considered
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.	